

<b>Notice of References Cited</b>	Application/Control No. 10/799,388	Applicant(s)/Patent Under Reexamination SELEZNEV ET AL.	
	Examiner Colleen P Cooke	Art Unit 1754	Page 1 of 1

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	B	US-6,537,689	03-2003	Schoop et al.	428/701
	C	US-5,231,074	07-1993	Cima et al.	505/434
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	L	US-			
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	N	WO 9858415	12-1998	PCT	Smith et al.	
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	U	Solovyov et al., "Ex-situ Post-deposition Processing for Large Area Y1BA2Cu3O7 Films and Coated Tapes", IEEE Transaction on APplied Superconductivity, Vol. 11, No. 1, March 2001, pp. 2939-2942.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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